

## QuickPRO-3DTM

Bench-Top, High-Speed, High-Accuracy, Non-Contact 3D Surface Profiler

- · Compact, bench-top unit with environmental enclosure
- Non-contact chromatic confocal sensor (Point or Line Scan)
- · 3D surface topography and transparent film thickness
- Integrated CMOS camera with co-axial or ring illumination
- Nanometer encoded X/Y/Z motion with magnetic linear motors and cross roller bearings



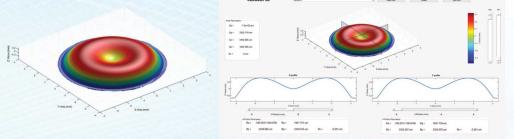
User-friendly CalcuSurf3D™ recipe generation, data acquisition, and surface analysis software permits optimized measurement sampling density for best coverage at highest throughput

 Extensive 3D surface plotting and data reporting functions conforming to DIN ISO The QuickPRO-3D™ is a compact (Bench-Top) non-contact metrology system designed from the ground-up for high-accuracy at high-speed for the most demanding measurements of surface topography and film thickness. The core measurement technology is based on high-bandwidth chromatic confocal white light sensing with motion provided by high-force linear motors and nanometer precision optical encoders. A solid granite platform with integrated temperature sensing provides the requisite structural and thermal stability needed to achieve the guaranteed 150 nm Z-axis measurement accuracy and sub-micron X/Y-axis positional accuracy.

## **APPLICATIONS:**

- Lenses (single & trays)
- Diamond-turned parts & molds
- MEMS
- Semiconductor
- Advanced Packaging
- 3D Printed Products
- Micro-fluidic cells
- LED & OLED
- Transparent films





SYSTEM			
Dimensions (L x W x H)	535 x 380 x 510 [mm]		
Weight	Approx. 60 kg		
System Controller	Includes motion control, sensor control, power supplies, ethernet interface to PC		
Power Requirements	110-220V AC, 50-60 Hz, 1 phase, 2 amps (220V), 5 amps (110V)		
MOTION			
Stage Travel (X x Y x Z)	100 mm x 100 mm x 50 mm		
Encoder Resolution (X $\times$ Y $\times$ Z)	20 nm x 20 nm x 1 nm		
Drive Type	Magnetic linear motor		
Bearing type	Cross Roller Bearing		
Flatness	Approx. 1 μm/100 mm		
Load Capacity	5 kg		
SENSOR			
Technique	Chromatic Confocal (Point & Line Scan)		
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SENSOR				
Technique	Chromatic Confocal (Point & Line Scan)			
Applications	Distance, Thickness			
Sampling	Point: 4,000 points/sec, Line Scan: 384,000 points/sec			
Available Probes	0.2 mm	1 mm	4 mm	
Lateral Resolution	1.7 μm	2.5 μm	4 μm	
Working Distance	5 mm	16 mm	37 mm	
Vertical Resolution	8 nm	40 nm	160 nm	
Vertical Accuracy	150 nm	400 nm	1.6 µm	
Maximum Slope	± 45°	±28°	±20°	
Thickness Measuring Range*	up to 0.3 mm	up to 1.5 mm	up to 6 mm	